



501.37854X00

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**  
**EXPEDITED PROCEDURE PURSUANT**  
**TO 37 CFR §1.116 REQUESTED**  
**Attn: Mail Stop AF**

Applicants: T. NAKATA, et al

Serial No.: 09/437,265

Filed: November 10, 1999

For: **METHOD FOR MEASURING DIMENSIONS AND ALIGNMENT OF  
THIN FILM MAGNETIC HEAD AND APPARATUS THEREFOR**

Group: 2877

Examiner: H. Lee

**AMENDMENT AFTER FINAL**

**Attn: Mail Stop AF**  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

April 19, 2004

Sir:

In response to the Office Action (Paper No. 1203) dated on December 19, 2003, please amend the above-identified application as follows. Applicants also request that an in-person Office Interview be scheduled and conducted as soon as possible to advance the prosecution of the application.

**Amendments to the Specification begin on page 2 of this paper.**

**Amendments to the Claims begin on page 6 of this paper.**

**Remarks/Arguments begin on page 10 of this paper.**